

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant(s): Yuanning Chen, et al.

Art Unit: 2813

Division of Serial No.: 10/294,265

Examiner: Jack S J Chen

Filed: Herewith

Docket: TI-35022.2

For: Use of Hafnium Silicon Oxynitride as the Cap Layer of the Sidewall Spacer

"EXPRESS MAILING" Mailing Label No. EV333324550US. I hereby certify that this paper is being deposited with the U.S. Postal Service Express Mail Post Office to Addressee Service under 37 CFR 1.10 on the date shown below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

Karen Vertz

11-21-03

Date

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**PRELIMINARY AMENDMENT**

Dear Sir:

Prior to the examination of the above-identified application, please amend as follows:

**IN THE SPECIFICATION:**

Please amend the Specification by inserting before the first line the following sentence:

--This is a division of Application No. 10/294,265, filed 11/14/2002, the entire disclosure of which is hereby incorporated by reference--.